

INFORMATION DISCLOSURE STATEMENT

Applicant	: Sherman
App. No	: 10/683,727
Filed	: October 10, 2003
For	: SEQUENTIAL CHEMICAL VAPOR DEPOSITION
Examiner	: Kelly M. Stouffer
Art Unit	: 1762

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 1 reference to be considered by the Examiner. There are no foreign patent references and/or non-patent literature listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed after the mailing date of a final action or after the mailing date of a Notice of Allowance. This Statement is accompanied by the fee set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

CERTIFICATION UNDER 37 C.F.R. § 1.97(e)(1)

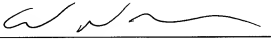
I hereby certify that each item of information contained in this Statement was first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than 3 months prior to the filing of this Information Disclosure Statement.

Appl. No. : 10/683,727
Filed : October 10, 2003

Docket No. ASMMC.9CP1DV1C1
Customer No. 20,995

Respectfully submitted,
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: March 3, 2018

By: 

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